

# HKTISC - Patent Search Service Request Form

We are pleased to announce that the Hong Kong Productivity Council (HKPC) has been successfully selected to establish a Technology and Innovation Support Centre (TISC) under the joint endorsement of China National Intellectual Property Administration (CNIPA) and the World Intellectual Property Organization (WIPO).

During the establishment period, HKPC is excited to offer a free pilot patent search service scheme. Our pilot patent search services include retrieving key patent information, such as identifying existing patents and identifying similar patent information. Please fill in the form below for search request. (Required questions are marked by an asterisk (\*))

Upon completing Questions 1-5, if you are interested in a free IP consultation session, please feel free to register under Question 6.

All information provided will be treated on a confidential basis. HKPC reserves the rights to conduct search based on valid information provided. The results are for reference only. HKPC accepts no liability for any errors or omissions in the search results, or for any actions taken based on the information provided.

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## 1. Which field does your invention belong to? \*

- ☐ Biotechnology / Life Sciences
- ☐ Chemical / Material
- ☐ Communications / Software / Information Services
- ☐ Electrical / Electronic Products
- ☐ Mechanical / Manufacturing
- ☐ Daily Necessities / Consumer Goods
- ☐ Others (Please specify)

## 2. What type of patent search are you interested in? \*

Please provide the required information under question 3 and/or 4, and choose the applicable country or region under question 5.

For basic patent information and competitor patent searches, if there are more than 10 results, the total number of results available in the specified country or region will also be provided so that a more refined search can be conducted, if required.

- ☐ **Basic patent information** - we will conduct patent search based on the intended company / competitor name and invention information provided (a maximum of 10 results per country will be shown including application number, application date, publication number, publication date, applicant and inventor name(s) (as applicable))
- ☐ **Competitors' patent(s)** - we will conduct patent search based on the intended company / competitor's name provided (a maximum of 10 results per country will be shown including application number, application date, publication number, publication date, applicant and inventor name(s) (as applicable))
- ☐ **Similar patent(s)** - we will conduct patent search to identify the top 3 patents that are most similar to your target invention based on the keywords provided
- ☐ Others (Please specify)

## 3. Please provide the name of the intended company for search (if not applicable, please mark "nil"). \*

Full name of company is strongly recommended to ensure accuracy of the search results.

**4. Please provide brief description of your invention (if not applicable, please mark "nil"): \***

Please enter technical field, keywords and technical description of your target invention.

**5. Which of the following countries or regions would you like to search for patents? \***

- ☐ Hong Kong, China
- ☐ Mainland China
- ☐ United States
- ☐ Europe
- ☐ Japan
- ☐ Others (Please specify)

**6. Which of the following activities would you like to be contacted for? \***

- ☐ IP enquiry
- ☐ IP training/ seminar
- ☐ IP news and updates
- ☐ Patent box enquiry
- ☐ Others (Please specify)

**7. Which of the following channels did you get this information from? \***

- ☐ HKPC website
- ☐ BEE website
- ☐ IP seminar/ webinar
- ☐ Facebook
- ☐ Referral
- ☐ Others (Please specify)

**8. Email Address \***

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**Please submit the completed form to our centre either by mail or in person.**

**Address:**

HKPC Building, 78 Tat Chee Avenue, Kowloon, Hong Kong